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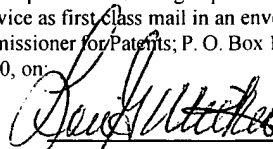
JPW AF

Docket No.: 0044XXXAX

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: MS: AF, Commissioner for Patents; P. O. Box 1450; Alexandria, VA 22313-1450, on:

April 9, 2008
(date)


Lori G. Witkin

In re: Application of: Miklos STERN, et al.

Serial No. : 09/777,076

Group Art Unit: 2876

Filed : February 5, 2001

Examiner: T. Le

For : SCANNER DEVICES AND METHODS USING
SURFACE EMITTING LASER DIODES

New York, New York
April 9, 2008

RESPONSE UNDER C.F.R. SECTION 1.116 –
EXPEDITED PROCEDURE

MS: AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated February 11, 2008, please amend this patent application as follows:

Amendments to the Claims are reflected in the Complete Listing of the Claims and begin on page 2 of this Response.

Remarks begin on page 6 of this Response.